

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Paul Alexander DE VRIES et al.

Serial No.: 10/516,889 ✓

Filed: December 3, 2004

For: METHOD FOR FRACTIONAL CRYSTALLISATION OF A MOLTEN METAL

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to Rules 56 and 98, Applicants hereby call the attention of the Patent Office to the references listed on the attached Form PTO 1449.

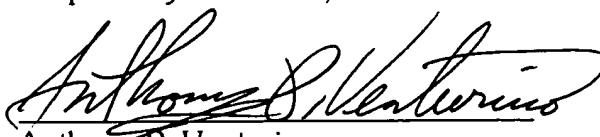
Applicants present these references so that the Patent Office may, in the first instance, determine any relevancy thereof to the presently claimed invention, see Beckman Instruments, Inc. v. Chemtronics, Inc., 439 F.2d 1369, 1380, 165 USPQ 355, 364 (5th Cir. 1970). Also see Patent Office Rule 104. Applicants respectfully request that these references be expressly considered during the prosecution of this application and made of record herein and appear among the "Reference Cited" on any patent to issue herefrom.

Respectfully submitted,

Date:

Dec. 29, 2004

By:



Anthony P. Venturino

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APV/kag  
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FORM PTO-1449 U.S. Department of Commerce  
(Rev. 4/92) Patent and Trademark Office

ATTY. DOCKET NO.  
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SERIAL NO.  
10/516,889

INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT

(Use several sheets if necessary)

APPLICANT  
Paul Alexander DE VRIES et al.

FILING DATE  
December 3, 2004

GROUP

**U.S. PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	4 5 8 1 0 6 2	04/86	Boutin			

**FOREIGN PATENT DOCUMENTS**

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
					YES	NO
6 1 5 5 9 0	01/49	GB				

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**

	International Publication No. WO 2004/005559, filed in the US National Stage on Dec. 3, 2004 as US Patent Application No. 10/516,888 in the name of DE VRIES et al.

EXAMINER

DATE CONSIDERED

**EXAMINER: Initial if citation is considered, draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.**